

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 1005

Applicants : Yasuo KOBAYASHI, et al.  
U.S. Serial No. : 10/568,461  
Filed : February 15, 2006  
Examiner : Reema PATEL  
Group Art Unit : 2812  
For : SEMICONDUCTOR DEVICE, METHOD FOR  
MANUFACTURING SEMICONDUCTOR DEVICE  
AND GAS FOR PLASMA CVD

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Mail Stop: Amendment**

Sir:

In response to the Office Action mailed on December 26, 2007, please amend the above-identified application as set forth below and consider the following remarks.

This Amendment is accompanied by a Petition for Extension of Time (Three Months) to extend the due date for response to June 26, 2008, and a payment for the sum of \$1050 of the extension fee (\$1050) by credit card.

Amendment to the claims begin on page 2.

Remarks begin on page 5.